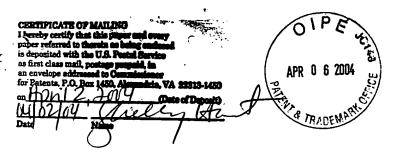
OUT STATE OF THE S		PTO/SB/21 (02-04) Approved for use through 07/31/2006. OMB 0651-0031
*	U.S. Pater	nt and Trademark Office: U.S. DEPARTMENT OF COMMERCE
Vunder the Paperwork Reduction Act of 1995, no per	rsons are required to respond to a collection Application Number	on of information unless it displays a valid OMB control number.
TRANSMITTAL	Filing Date	10/646,528
FORM	First Named Inventor	August 22, 2003
) TOKIN		Kenneth Collins, et al.
(to be used for all correspondence after initial filing)	Art Unit	2812
·	Examiner Name	Unknown
Total Number of Pages in This Submission 4	Attorney Docket Number	006915 P05
EN	NCLOSURES (Check all that	(apply)
	(0.000.0.0.0.0.0.0.0.0.0.0.0.0.0.0.0.0.	After Allowance communication
Fee Transmittal Form	Drawing(s)	to Group
Fee Attached	Licensing-related Papers	Appeal Communication to Board of Appeals and Interferences
Amendment/Reply	Petition	Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)
After Final	Petition to Convert to a Provisional Application	Proprietary Information
Affidavits/declaration(s)	Power of Attorney, Revocation Change of Correspondence Address	Status Letter
	Terminal Disclaimer	Other Enclosure(s) (please
Extension of Time Request		Identify below):
Express Abandonment Request	Request for Refund	
X Information Disclosure Statement	CD, Number of CD(s)	
Certified Copy of Priority Document(s)	maiks	
Response to Missing Parts/ Incomplete Application		
Response to Missing Parts		
under 37 CFR 1.52 or 1.53		
SIGNATURE	OF ADDUCANT ATTORN	EV 00 405117
Firm	OF APPLICANT, ATTORNI	EY, OR AGENT
or Robert M. Wallac	ce Reg. No. 29,	,119
Signature // // // Signature	Mele	
Date	<u> </u>	
СЕРТИ	FICATE OF TRANSMISSION	I/MAILING
I hereby certify that this correspondence is being fa	csimile transmitted to the USPTO or	deposited with the United States Postal Service with ents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Typed or printed name		
Sheelly Har	t // /	
Signature	my that	Date 04627209
This collection of information is required by 37 CFR 1.5. The process) an application. Confidentiality is governed by 35 to	ne information is required to obtain or retain	in a benefit by the public which is to file (and by the USPTO to

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. [122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450, DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



PATENT

Attorney Docket No. 6915 P05 RW Ref. No. APM/001-02-CP1-5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applica Kenneth CO	tion of: LLINS, et al.)) Group	Art	Unit:	2812
IMPLANTATION	SMA IMMERSION ION PROCESS USING A PLASMA LOW DISSOCIATION AND LOW A VOLTAGE) Examin)))	er:	Unknov	√n
Serial No.:	10/646,528)			
Filing Date:	August 22, 2003)			

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace

Registration No. 29,119 Attorney for Applicants

Robert M. Wallace Patent Counsel 2112 Eastman Avenue, Suite 102 Ventura, CA 93003 (805) 644-4035 INFORMATION
DISCLOSURE
STATEMENT BY APPRISANT

Sheet 1 of 1

APR 0 6 2004

Application Number:

10/646,528

Filing Date:

August 22, 2003

First Named Inventor:

Kenneth COLLINS, et al.

Group Art Unit: Examiner Name:

2812 Unknown

Attorney Docket Number:

6915 P05

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
	US-4,892,7523	01-09-1990	WANG ET AL.	427	38	10-25-1988
	US-5,040,046	08-13-1991	CHHABRA ET AL.	357	54	10-09-1990
	US-5,643,838	07-01-1997	DEAN ET AL.	437	238	09-03-1993
	US-5,660,895	08-26-1997	LEE ET AL.	427	579	04-24-1996
	US-5,888,413	03-30-1999	OKUMURA ET AL.	216	68	05-30-1996
	US-6,096,661	08-01-2000	NGO ET AL.	438	788	12-15-1998
	US-6,174,450 B1	01-16-2001	PATRICK ET AL.	216	61	04-16-1997
	US-6,174,743 B1	01-16-2001	PANGRLE ET AL.	438	14	12-08-1998
	US-6,303,519 B1	10-16-2001	HSIAO	438	758	07-20-2000
	US-6,426,015 B1	07-30-2002	XIA ET AL.	216	62	12-14-1999

FOREIGN PATENT DOCUMENTS

Examiner Initials	Foreign Patent Document	Publication Date	Country	Name of Patentee or Applicant of Cited Document	Translation? (Yes/No/n/a)

Examiner | NON PATENT LITERATURE DOCUMENTS Initials

Van de Ven, Evert P., Connick, I-Wen, and Harrus, Alain S., "ADVANTAGES OF DUAL FREQUENCY PECVD FOR DEPOSITIONOF ILD AND PASSIVATION FILMS," *IEEE*, Proceedings of VMIC Conference, June 12-13, 1990, pp. 194-201.

Examiner's Signature:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.